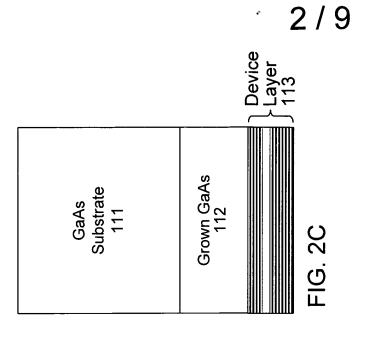


Replacement Sheet Serial No. 10/735,695 Filed: 12/16/2003 Title: Method of Fabrication of a Support Structure For A Semiconductor Device Glen Carey et al. Dkt No. 11809/27 **ARC** 116 Optical aperture 117 Wafer thinning Grown GaAs 112 Electrical contacts 115 Grown GaAs 112 GaAs Substrate 111 FIG. 2D

ARC and aperture



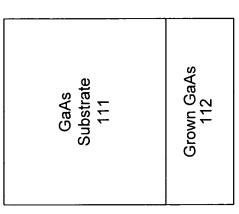


FIG. 2B

NECSEL fabrication

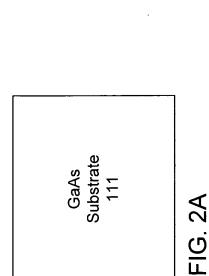


FIG. 3A

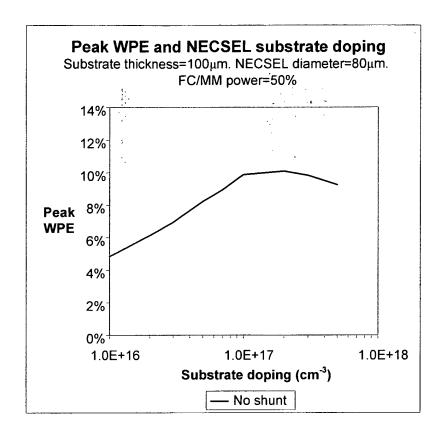
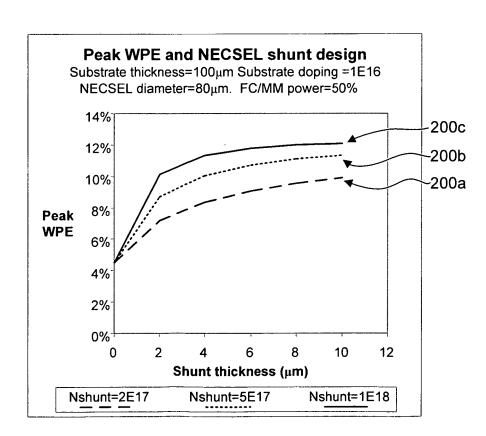
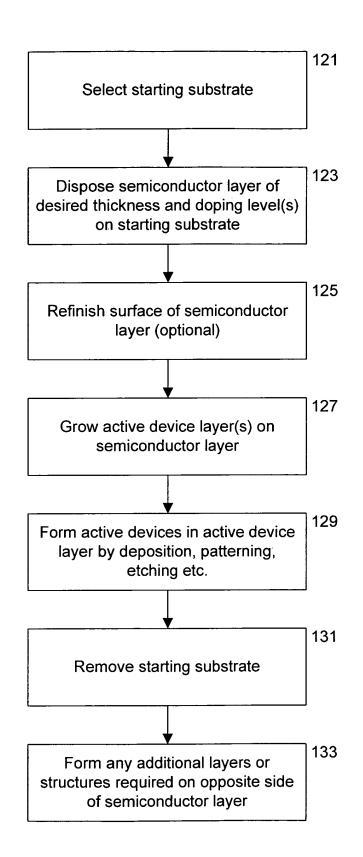


FIG. 3B



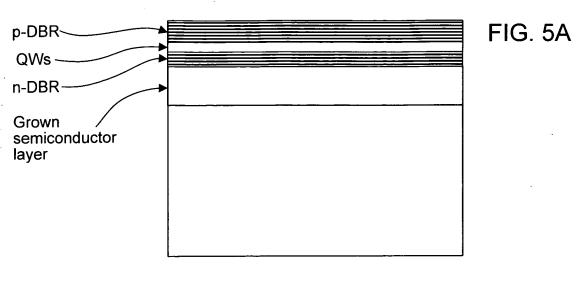
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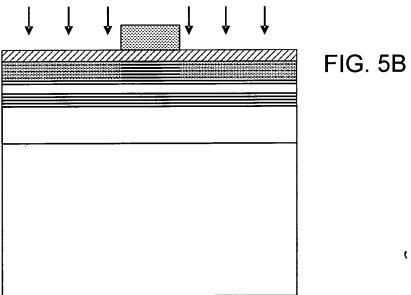
FIG. 4

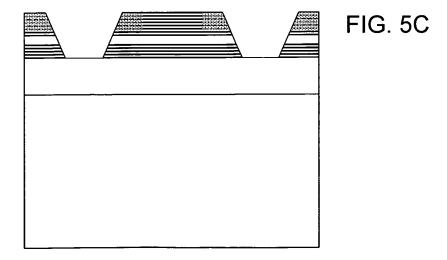


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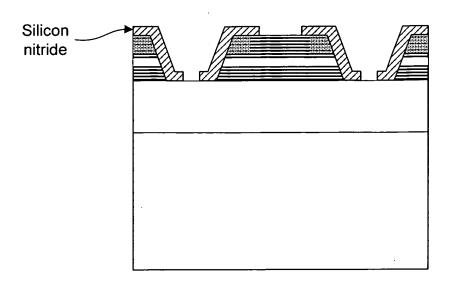


FIG. 5D

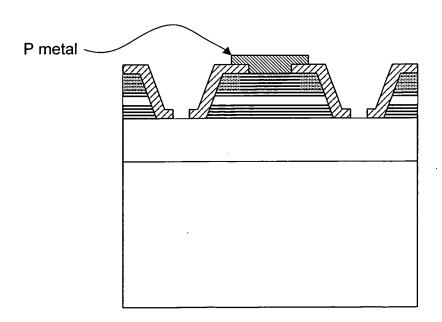


FIG. 5E

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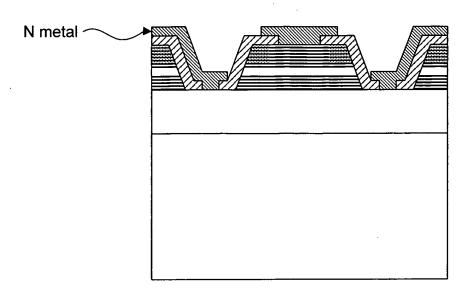


FIG. 5F

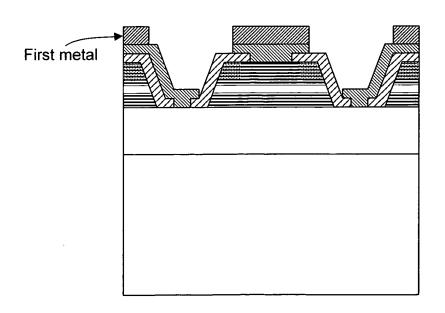


FIG. 5G

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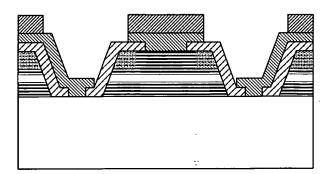


FIG. 5H

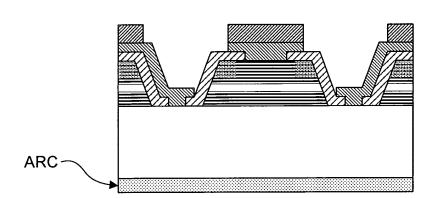


FIG. 51

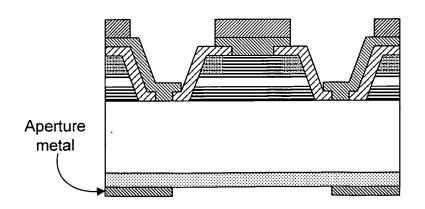


FIG. 5J

Replacement Sheet

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